Test Grind Request Form

Submit Date	Requested test completion date Wafer arrival date at DISCO
Customer Information	
Company Name	
Address	
Contact Person	
Email Address	Phone Number
Test Grind Infor	mation
ls someone plannir	ng to attend the testing? Yes No
Test Purpose	
Key Evaluation	
Points & Priority	
Material	Other
Wafer Size	+ Info
Machine	+ Info
Wafer Protection	+ Info
Final Thickness, Tol	erance, and Surface Roughness Targets (please leave unknowns blank)
Thickness #1 (µm)	Thickness Variation (+/- μm) Surface Roughness (Rmax μm)
Thickness #2 (μm)	Thickness Variation (+/- μm) Surface Roughness (Rmax μm)
Thickness #3 (μm)	Thickness Variation (+/- μm) Surface Roughness (Rmax μm)
Please describe any wafer frontside topography such as bumps or structures on the surface	
Grinding Wheel to	be used (optional input)
Z1 (rough grind)	Z2 (fine grind) Z3 (polish)
+ Info	